

## **PATENT APPLICATION**

Sheet 1 of 1

<b>FORM PTO-1449</b>  <b>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</b>  (Use several sheets if necessary)	<b>ATTY. DOCKET NO.</b>	<b>SERIAL NO.</b>
	10010746-1	101664947
	<b>APPLICANT</b>	
	Jonah A. HARLEY, et al.	
<b>FILING DATE</b>	<b>GROUP</b>	
9/22/2003	2834	

## **REFERENCE DESIGNATION**

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

		DOCUMENT NUMBER	DATE	NAME	TRANSLATION
					YES NO

**OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)**

WT	Legtenberg, Rob, et al., "Comb-drive actuators for large displacements", J. Micromech. Microeng. 6 (1996), June 4, 1996, p.p. 320-329.
WM	Lee, Chris Seung-Bok, et al., "Multiple depth, single crystal silicon microactuators for large displacement fabricated by deep reactive ion etching", Solid-State Sensor and actuator workshop, Hilton Head Island, South Carolina, June 8-11, 1998, p.p. 45-50.
EXAMINER	DATE CONSIDERED 3/21/05

\* Copies of these references are not enclosed pursuant to 37 CFR 1.98(d). (See accompanying IDS)